	Application No.	Applicant(s)
Notice of Allemahility	_10/603,515	GRANNEMAN ET AL.
Notice of Allowability	Examiner	Art Unit
	Parviz Hassanzadeh	1763
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85). NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT Ri	(OR REMAINS) CLOSED in this apport of the appropriate communication GHTS. This application is subject to	olication. If not included
1. This communication is responsive to <u>5/13/04</u> .		
2. The allowed claim(s) is/are <u>1-27</u> .		
3. A The drawings filed on 24 June 2003 are accepted by the Ex	aminer.	
4.	been received. been received in Application No uments have been received in this r f this communication to file a reply of this application. ted. Note the attached EXAMINER's reason(s) why the oath or declarate be submitted. n's Patent Drawing Review (PTO-9 Amendment / Comment or in the Off the Comment of the C	complying with the requirements S AMENDMENT or NOTICE OF ion is deficient. 48) attached fice action of ions in the front (not the back) of ions in the problem in the pack) of ions in the pack in
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/08) Paper No./Mail Date 12/8/03 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal Pa 6. ☐ Interview Summary (i Paper No./Mail Date 7. ☐ Examiner's Amendme 8. ☑ Examiner's Statemen 9. ☐ Other	PTO-413), ent/Comment
·		Parviz Hassanzadeh Primary Examiner Art Unit: 1763

DETAILED ACTION

Allowable Subject Matter

Claims 1-27 are allowed.

The following is an examiner's statement of reasons for allowance: a pair of blocks for a reactor for thermal processing of a substrate, comprising:

a first reactor block configured to extend across a top major surface of the substrate, and a second reactor block configured to extend across a bottom major surface of the substrate, wherein the first reactor block and the second reactor block having a plurality of gas passages configured to face the top major surface and the bottom major surface of the substrate respectively, wherein each of the first reactor block and the second reactor block having a thickness perpendicular to the substrate of greater than about 10 mm; and

wherein the first and the second reactor blocks are configured to surround a substrate with gas cushions to suspend the substrate between the first and the second reactor blocks upon assembly of the first and the second reactor blocks in the reactor and upon retention of the substrate therebetween.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Terminal Disclaimer

The terminal disclaimer filed on 5/13/04 disclaiming the terminal portion of any patent granted on this application which would extend beyond the expiration date of US Patent Nos.

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6,183,565 B1 and 6,461,439 B1 has been reviewed and is accepted. The terminal disclaimer has been recorded.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Parviz Hassanzadeh whose telephone number is (571)272-1435. The examiner can normally be reached on Tuesday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Mills can be reached on (571)272-1439. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

P. Hassanzadeh Parviz Hassanzadeh Primary Examiner Art Unit 1763

June 15, 2004